AMENDMENT TRANSMITTAL LETTER (Large Entity)							Docket No.			
Applicant(s): Hirohiko Nishiki										
- Internation of the state of t							SLA0454			
	Serial No		g Date	Examiner			Group Art Unit			
10/021,342		December 12, 2001		Tarifur R. Chowdhury			2871			
Invention: Sys	Invention: System and Method for Forming Ozone Resistant IC and LCD Structures (As Amended)									
TO THE COMMISSIONER FOR PATENTS:										
		10 THE	COMMISSION	ER FO	R PATENTS:					
Transmitted herewith is an amendment in the above identified application.										
The fee has been	The fee has been calculated and is transmitted as shown below.									
CLAIMS AS AMENDED										
		REMAINING MENDMENT	HIGHEST# PREV. PAID FOR		MBER OF EXTRA AIMS PRESENT	. RA	ATE	ADDITIONAL FEE		
TOTAL CLAIMS		5 -	29 =		0	x \$1	8.00	\$00.00		
INDEP. CLAIMS		2 -	7 =		0	× \$8	6.00	\$0.00		
Multiple Dependent Claims (check if applicable)								\$0.00		
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$00.00				
No additional fee is required for amendment.  Please charge Deposit Account No. 19-1457 in the amount of A duplicate copy of this sheet is enclosed.  A check in the amount of to cover the filling fee is enclosed.  The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.  A duplicate copy of this sheet is enclosed.  Any additional fees required under 37 C.F.R. 1.16.  X Any patent application processing fees under 37 C.F.R. 1.17.  Dated: DECEMBER 8, 2003										
I hereby certify that this correspondence is being facsimile transmitted to the United States. Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on December 8, 2003.  David C.Ripma, Reg. No. 27.672  Note: Each paper must have its own certificate or transmission, or this certificate must identify each submitted paper. The papers submitted include:										
							page(s)			
X Response under 37 CFR § 1.111  Attachments							10	page(s) page(s)		
	Notice of Non-Compliant Amendment (Voluntary Revised Practice)  page									
Total pages, including this Transmittal: 12										

IN THE	UNITED STATES PATENT AND	D TRADEMARK OFFICE	RECEIVED
İn Re Applie	cation of:	)	CENTRAL FAX CENTER
Inventors:	Hirohiko Nishiki	) )	DEC 0 8 2003
Serial No.:	10/021,342	) ) ATTORNEY FILE NO. ) SLA 454	OFFICIAL
Filed:	December 12, 2001	) SLA 404 )	OFFICIAL
		) Customer No.: 27518	,
Title:	SYSTEM AND METHOD FOR FORMING OZONE	) )	
	RESISTANT IC AND LCD STRUCTURES	) Confirmation No.: 6170	
		Examiner: T.R. Chowdhur	7

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT AND REQUEST FOR RECONSIDERATION

In response to a Final Office Action dated November 5, 2003, please amend and reconsider as follows.

The claims begin at page 2 of this paper.

Remarks begin at page 6 of this paper.